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## BIB DATA SHEET

CONFIRMATION NO. 8920

SERIAL NUMBER	FILING or 371(c) DATE RULE	CLASS	GROUP ART UNIT	ATTORNEY DOCKET NO.
10/773,333		257	3663	Q77321

## APPLICANTS

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## \*\* CONTINUING DATA \*\*\*\*\*

## \*\* FOREIGN APPLICATIONS \*\*\*\*\*

JAPAN 042083/2003 02/20/2003

## \*\* IF REQUIRED, FOREIGN FILING LICENSE GRANTED \*\*

05/06/2004

Foreign Priority claimed	<input checked="" type="checkbox"/> Yes <input type="checkbox"/> No	STATE OR COUNTRY	SHEETS DRAWINGS	TOTAL CLAIMS	INDEPENDENT CLAIMS
35 USC 119(a-d) conditions met	<input checked="" type="checkbox"/> Yes <input type="checkbox"/> No				
Verified and Acknowledged	<input checked="" type="checkbox"/> Yes <input type="checkbox"/> No	<input type="checkbox"/> Met after Allowance /JOHANNES P MONDT/ Examiner's Signature Initials	JAPAN	8	28
					3

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## TITLE

Thin film transistor substrate and method for manufacturing the same

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